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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Ivo Raaijmakers)	Group Art Unit 3743
)	
Appl. No.	:	09/584,656)	CERTIFICATE OF FAX TRANSMISSION
)	I hereby certify that this correspondence and all marked
Filed	:	May 30, 2000)	attachments are being facsimile transmitted to the
)	Patent and Trademark Office on the date shown below:
)	
For	:	APPARATUS FOR THERMAL)	January 2, 2002
		TREATMENT OF)	(Date)
		SUBSTRATES)	<i>Adel S. Akhmr</i>
)	Adel S. Akhmr, Reg. No. 41,394
Examiner	:	L. Leo)	

RESPONSE TO OFFICE ACTION

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

In response to the Office Action mailed on October 3, 2001, please amend the above-captioned application as indicated below.

IN THE CLAIMS:

Please delete Claims 60-64 and 66 in accordance with an earlier election of species.

Please amend Claims 70 and 75 as follows:

70. (Amended) The cooling mechanism of Claim 65, wherein the support structure and the thermal exchange member are configured to position the substrate within the process chamber in the cooling position.

75. (Amended) The processing reactor of Claim 72, wherein the thermal exchange member is one of the plurality of walls defining the chamber.